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Flexible Soft X-Ray Image Sensors based on Metal Halide Perovskites With High Quantum Efficiency

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1 FRONT MATTER

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Title: Flexible Soft X-ray Image Sensors based on Metal Halide Perovskites with High Quantum Efficiency

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29 Abstract

Soft X-ray imaging is a powerful tool to explore the structure of whole cells, probe large 30 volumes of material with nanometer resolution, and investigate the energetic phenomena 31 in the universe. Conventional soft X-ray image sensors are by and large silicon-based 32 charge coupled devices that suffer from low frame rates, complex fabrication processes, 33 required cooling below -60 °C, and mechanical inflexibility. Here, we report a soft X-ray 34 photodiode based on a low-cost, solution-processed metal halide perovskite with 35 comparable performance to commercial Si-based devices. Design of the device structure 36 minimized the optical loss due to the shadowing of insensitive layers, while a 37 multidimensional perovskite heterojunction was gneerated to reduce the dark current 38 density and improve the quantum efficiency. A high responsivity of 0.161 A/W (@500 39 eV), an excellent quantum efficiency of 8×10^3 %, a low dark current density of 1.18×10^{-9} 40 A/cm², and a short response/decay time of 81/28 µs were achieved without cooling. Our 41 strategy promoted a record responsivity and quantum efficiency, several orders of 42 magnitude greater than the previously achieved and comparable to the commercial Si 43 based devices. Flexible and curved soft X-ray imaging arrays were fabricated based on 44

- 45 46
- this high-performance device structure, demonstrating stable soft X-ray response and
- 46 sharp imaging capabilities. This work highlights the low-cost and efficient perovskite
- 47 photodiode as a strong candidate for the next-generation soft X-ray imaging sensors.
- 48
- 49 **Teaser**
- 50 Multidimensional perovskite heterojunction and delicate design of the device structure
- 51 enhances the performance of perovskite soft X-ray photodiode.
- 52

53 MAIN TEXT

54

55 Introduction

X-rays, a vital tool for scientific research and a multibillion-dollar industry, (1) can be 56 divided into the hard and soft X-ray regimes depending on the photon energy. With 57 photon energy greater than 10 keV, hard X-rays are penetrating and of great importance in 58 medical diagnosis, security inspection, t name a few. (2) Soft X-rays have photon energies 59 between several hundreds to thousands of electron-volts, are absorbed mmore readily and 60 have a smaller absorption. Soft X-rays are mostly used in microscopy, spectroscopy, X-61 ray astronomy and lithography. (3) The "water window" spectral region lies between the 62 carbon (284 eV) and oxygen (540 eV) K shell absorption edges. (4) Since water is nearly 63 an order of magnitude more transparent than organics in this region, microscopic analysis 64 of cells in their natural aqueous environment is possible. (5) Soft X-ray tomography in he 65 "water window" region allows for the 3D imaging of cellular ultrastructures with a 66 resolution up to 25 nm, without the need for chemical or mechanical modification. (6) 67 Apart from biological applications, soft X-ray microscopy can also probe large volumes of 68 materials with nanometer resolution along with exquisite chemical, electronic and bond 69 orientation contrast. (7) Soft X-ray telescopes onboard various satellites help collect key 70 information about energetic phenomena in the universe. (8) For these applications, soft X-71 ray detectors and imaging sensors with high responsivity, low noise, low weight, and high 72 cost-efficiency are highly desired. (9) 73

74 Silicon-based charge coupled devices (CCDs) with direct detection mechanisms are 75 commonly used for soft X-ray imaging at present, but they have many shortcomings, including costly fabrication processes, low frame rates, mechanical fragility, and cooling 76 requirement from -60 °C to -130 °C. (10-12) Recently, a number of novel materials, e.g. 77 CsPbBr₃ perovskite nanocrystals, (13) CrSiTe₃ flake, (14) SnS nanosheets, (9) and 78 $Cs_{0.1}FA_{0.9}PbI_3$ perovskite (FA: formamidine) films (15) have been explored for the direct 79 detection of soft X-ray at room temperature. Among these materials, metal halide 80 perovskites appear promising, since they have superior electrical and optoelectrictronic 81 82 properties, such as large attenuation coefficients, long electron-hole diffusion lengths, high mobilities, high defect tolerances, and strong radiation tolerances. (16) In addition, 83 perovskites can be produced as large-area films using low-cost solution processes, 84 enabling the fabrication of cost-effective imaging sensor arrays, rather than individual 85 photodetectors. While perovskite-based detectors in the hard X-ray region are widely 86 reported to outperform commercial devices, (17-19) perovskite-based soft X-ray detectors 87 are less explored. Liu et al. first introduced inkjet-printed CsPbBr₃ perovskite quantum 88 dots for soft X-ray detection and successfully demonstrated direct detection of soft-X-ray-89 induced photocurrent with both rigid and flexible substrates. (13) The device showed a 90 large dark current and low photon-to-dark current ratio, possibly due to the simple metal-91

92 semiconductor-metal (MSM) structure adopted. In contrast, photodiode structures have low dark current, fast response speed, and low power consumption. (19-22) The n-i-p 93 diode configuration in soft X-ray detectors was first used by Shabbir et al., and their 94 $Cs_{0.1}FA_{0.9}PbI_3$ thin film based device achieved high performance across the soft and hard 95 X-ray region. (15) Nevertheless, the soft X-ray responsivity of these reported devices was 96 much lower than the theoretical limit of perovskite and also commercial Si-based devices. 97 98 The severe optical loss and the photo-generated-carriers losses were the main reasons hindering the development of the perovskite-based soft X-ray photodiodes. 99

In this work, soft X-ray detectors based on low-cost, solution-processed FAPbI₃ 100 perovskites are shown to have a performance that is comparable to commercial Si-based 101 photodiodes. By designing the device structure to minimize the shadowing of insensitive 102 layers and the generation of a multidimensional perovskite heterojunction to reduce charge 103 carrier recombination, a high responsivity of 0.161 A/W (@500 eV) and an excellent 104 quantum efficiency of 8×10³ % were achieved. In addition, a low dark current density of 105 1.18×10^{-9} A/cm² at -2.5 mV and a short response/decay time of 81/28 µs were achieved. 106 Based on this high-performance device structure, flexible and curved imaging arrays 107 show stable soft X-ray response and excellent uniformity. Clear contrast images were 108 achieved with a 10×10 crossbar array on glass. This work paves the way for perovskite 109 photodiodes as practical, highly cost-effective and sensitive imager sensors for soft X-ray 110 imaging systems. 111

112 **Results**

A Soft X-ray photodiode was built with a structure of indium tin oxide 113 (ITO)/SnO₂/perovskite/poly[bis(4-phenyl) (2,4,6-trimethylphenyl)amine] (PTAA)/ Au 114 (Fig. 1A). As different metal halide perovskite shows similar attenuation lengths in the 115 soft X-ray region (fig. S1), we chose FAPbI₃ perovskite with well-developed fabrication, 116 high thermodynamics stability and preferable photovoltaic properties for this work. To 117 date, the most efficient perovskite solar cells usually use FA-rich perovskite as the light 118 absorber layer, demonstrating the superiority of FAPbI₃ perovskite.(23) The attenuation 119 lengths of soft X-ray in FAPbI₃ perovskite and Si are taken from the CXRO database and 120 shown in Fig. 1B.(24) Si shows a steep increase of attenuation length at soft X-ray region 121 from ~40 nm (@150 eV) to ~2.7 μ m (@1000 eV). The small attenuation length at lower 122 energy means that most absorption occurs in the defect-abundant surface region and the 123 large attenuation length at higher energy reduces the attenuation efficiency of the active 124 layer. These diminish diminish the performance of Si based soft X-ray detectors. 125 However, FAPbI₃ perovskite shows stable attenuation lengths of serval hundreds of 126 nanometers across the soft X-ray region, making it a suitable material for soft X-ray 127 detection. The FAPbI₃ perovskite was obtained by a solution-based spin-coating process 128 with a thickness of 750 nm, as shown in the cross-sectional scanning electron microscope 129 (SEM) image in fig. S2. This thickness leads to an attenuation efficiency of $\sim 90\%$ at 500 130 eV. 131

132 The quality of the solution processed FAPbI₃ film was probed by multiple methods. 133 Synchrotron-based grazing-incidence wide-angle X-ray scattering (GIWAXS) shows 134 intense reflections at $q \approx 1, 1.4, 1.7, 2.0, \text{ and } 2.2 \text{ Å}^{-1}$ (Fig. 1C and fig. S3), arising from 135 the (100), (110), (111), (200) and (210) planes of α -phase FAPbI₃. (25) No preferred 136 orientation of the FAPbI₃ crystal was observed, suggesting the polycrystalline nature of

- 137 the sample. The top-view SEM image of the film shows an average grain size of $\sim 1 \,\mu m$ 138 (Fig. 1D). The absorption edge of the perovskite is located at 810 nm, consistent with the 139 steady-state photoluminescence (PL) peak location (Fig. 1E). No sub-bandgap emission 140 was observed in the PL spectra, confirming the high quality of the solution-processed 141 perovskite film.
- 142 To estimate the functionality of the photodiode, the device response to visible light was first studied. As shown in the current-voltage (I-V) curves in Fig. 2A, the photodiode 143 shows suppressed dark current under reverse bias. When 520 nm light (1.3 mW/cm^2) was 144 turned on, typical photovoltaic behavior with high short-circuit current and large open-145 circuit voltage was observed, verifying a strong built-in electric field inside the 146 photodiode. Unlike visible light, one main challenge for achieving high-performance 147 detector in soft X-ray region is that soft X-ray shows small attenuation length in nearly all 148 materials. (26) This leads to severe optical loss in insensitive layer on the active region in 149 the detector and a special design of the device structure is needed. (26) Soft X-rays must 150 be illuminated from the top side of our perovskite-based photodiode, since they penetrate 151 the thick substrate. The top Au and PTAA layers are undesired "dead layers" that 152 attenuate the light passing into perovskite. So, their thickness must be minimized while 153 preserving the functionality of the photodiode (fig. S4). By exploring the device 154 performance as a function of Au and PTAA layer thickness (Fig. 2B), thicknesses of 10 155 nm and 65 nm, respectively, were found to be optimal. For the fabrication of a high-156 performance soft X-ray photodiode, the modified structure ensures that the perovskite will 157 absorb most of the incident soft X-rays and convert them into an electric signal (Fig. 2C). 158 An absorption efficiency (defined as the ratio of the power absorbed by the active layer to 159 the total incident power) greater than 50% was achieved across the soft X-ray region (fig. 160 S5). 161
- An obvious photoresponse is observed in our photodiode when illuminated by 500 eV soft 162 X-rays with a photon flux of 6.92×10^{10} photons/s (Fig. 2D). A short-circuit current of 61.3 163 nA and an open-circuit voltage of 0.26 V were achieved. When working in the self-164 powered mode, meaing no applied external bias, the photodiode showed fast and stable 165 response to the periodic exposure to 500 eV soft X-ray pulses (Fig. 2E). Under 166 illumination, a 10²-fold increase in the current was observed. For soft X-rays with photon 167 energies from 300 to 800 eV, the device maintained significant response and good stability 168 To verify the response characteristics of the perovskite based soft X-ray (fig. S6). 169 photodiode more clearly, two figure-of-merits commonly used in commercial soft X-ray 170 detectors were calculated. The responsivity (R) of the photodiode is defined as the 171 photocurrent per incident radiation power: (27) 172
- 173 $R = I_{\text{light}} / (\varphi \times E \times e)$

174 Where I_{light} is the photocurrent, *e* is the charge of electron, φ represents the photon flux, 175 and *E* denotes the photon energy of the incident soft X-ray. The quantum efficiency (*QE*) 176 can be calculated as: (26)

177 $QE = I_{\text{light}} / (\varphi \times e) = R \times E$

The *QEs* of this perovskite-based soft X-ray photodiode at different photon energies are shown in Fig. 2F. The device is characterized with a *QE* and *R* of 5.53 and 11 mA/W, respectively, for 500 eV soft X-ray. The *QE* value exceeds 100% because the energetic soft X-ray photons can induce secondary electron cascades in semiconductors with multiple electrons being generated from one soft X-ray photon. (*1*) The theoretical *QE* of the perovskite semiconductor can be calculated as: (28)

184
$$QE_{\text{theoy}} = E/W = E/(2E_{\text{g}}+1.43)$$

185 Where W is the ionization energy of perovskite and E_g stands for the bandgap of the 186 material. Given the bandgap of FAPbI₃ of 1.41 eV (fig. S7), QE_{theory} is 118 for this material 187 for 500 eV soft X-rays. With an absorption efficiency of 64%, the theoretical QE and R 188 limits of our device should be 76 and 0.15 A/W, respectively (fig. S8). The QE and R of 189 our device achieved here are still far below the theoretical value sugesting a fast 190 recombination of photogenerated carriers in the perovskite based soft X-ray photodiode.

To further improve the performance of the perovskite photodiode, a multidimensional 191 perovskite heterojunction (MPH) was produced by epitaxial grow of 2D perovskites on 192 the 3D FAPbI₃ surface. Significant performance improvement with lower dark current and 193 better soft X-ray response was observed with the MPH (Fig. 3A). The dark current density 194 of the device decreased by nearly one order of magnitude, reaching a value of 1.37×10^{-8} 195 A/cm² at -0.5 V and 1.18×10⁻⁹ A/cm² at -2.5 mV. In addition, the photocurrent of the 196 detector increased by nearly one order of magnitude. For the MPH device, a QE of 80 and 197 a R of 0.161 A/W were achieved in the self-powered mode. These values are very close to 198 199 the theoretical limits of the device, indicating a high charge collection efficiency for the MPH. This high charge collection efficiency can also be demonstrated by the spectral 200 response of the MPH in the visible region, where a highest quantum efficiency >85% was 201 achieved without the blocking of Au and PTAA layers (fig. S8). When exposed to 202 intermittent illumination of 500 eV soft X-ray, the MPH photodiode maintained fast 203 response and good reproducibility (Fig. 3B). Due to the lower dark current and higher 204 photocurrent, the ratio between the photo and dark current reached 10^3 after the 205 introduction of MPH. The rise/decay time of one photodetector is defined as the time 206 delay between 10% and 90% of the steady photocurrent at the rising and falling edges. As 207 shown in Fig. 3C, the response/decay time of the MPH device under 500 eV soft X-ray is 208 ~10 ms. This value is not very precise, since the smallest time interval of the parameter 209 analyzer used here is 10 ms. For reference, the device shows rise/decay of 81/28 µs with 210 visible light when an oscilloscope with much higher time resolution was used (fig. S9). 211 When working with different external biases and soft X-ray with different photon energies, 212 the MPH device maintained a fast response and good stability (Figs. 3C and 3D). To 213 further explore the stability of the device, fatigue tests were performed with the device 214 being exposed for to soft X-rays for 1 sec with a 2 sec rest period between each exposure 215 (Fig. 3F). After 130 cycles of exposure and a total absorption of $\sim 9 \times 10^{12}$ photons, which is 216 far larger than the durability requirement of commercial soft X-ray imaging sensors ($\sim 10^{10}$ 217 218 photons), (10, 29) the photo and dark current of the MPH device show negligible deterioration, refecting the good stability of our device. 219

To further explore the origin of the performance improvement after the introduction of the MPH, GIWAXS measurements were performed to probe the crystallization and

orientation of perovskite films. Additional reflections at $q \approx 0.25, 0.5, 0.75$ Å⁻¹ are 222 223 observed, arising from the (020), (040) and (060) planes, respectively, of $OA_2(FA)_{n-1}$ $_{1}Pb_{n}I_{3n+1}$ 2D perovskite with n=2 (OA: n-Octylammonium) (Fig. 4A).(30, 31) These Bragg 224 spots, concentrated along the q_z direction, suggest the 2D perovskite is oriented parallel to 225 226 the substrate (fig. S11).(31) When different incidence angles were used, the 2Dperovskite-related peaks remain unchanged, while the 3D(100) signal shows a gradual 227 increase with the increasing incidence angle (Fig. 4B). The peak area ratio between 228 $(040)_{n=2}$ and 3D(100) decreases with an increase of the incidence angle and, therefore, 229 penetration depth, indicating the surface-concentrated distribution of the 2D perovskite 230 (Fig. 4C).(32, 33) An additional peak of n=2 phase 2D perovskite in 561 nm is observed in 231 the UV-vis absorption spectrum of MPH sample, in line with the GIWAXS 232 characterization results (fig. S12).(30) Given the results described above, the crystal 233 structure of the MPH is shown in fig. S13. The surface chemistry of the perovskite film 234 235 was investigated by X-ray photoelectron spectroscopy (XPS). Apart from the FA induced peak at 400.2 eV, the N 1s spectra of MPH sample show an additional peak at 401.8 eV, 236 which is ascribed to the OA cation (fig. S14).(34) The C=O peak at 288.1 eV in C 1s 237 spectra is significantly suppressed after the introduction of MPH (Fig. 4D), indicating the 238 239 protection effect of the 2D perovskite against oxygen and moisture. (35) The time-resolved photoluminescence (TRPL) spectra of the MPH and control film on ITO/SnO₂ substrate 240 are shown in Fig. 4E and the corresponding carrier lifetimes were determined from bi-241 242 exponential fitting. After the introduction of MPH, the average carrier lifetime of the perovskite increased from 6.8 ns to 35.0 ns, indicating a reduction of nonradiative 243 recombination and defect states in the perovskite (Table S1).(33) This is also confirmed by 244 the space-charge-limited current (SCLC) measurements (Fig. 4F), where the trap densities 245 were found to be 8.3×10^{15} and 6.6×10^{15} for the control and MPH sample, respectively.(36) 246

247 Furthermore, we examined the photoexcitation and transport process of charge carriers inside the photodiode by transient absorption (TA) spectroscopy. A 2D pseudo-color plot 248 of the TA spectroscopy of MPH film on glass substrate is shown in Fig. 4G. The blue 249 region at 1.6 eV represents the photoinduced bleaching signal from band filling effect. (37, 250 38) The red region at 1.3-1.6 eV and the dark yellow region at 1.8-2.0 eV come from the 251 bandgap renormalization effects and transient reflections, respectively. (39, 40) 252 Normalized TA spectra at the early stage after photoexcitation shows a broadened high-253 energy tail (Fig. 4H and fig. S15), due to the non-thermalized hot carriers with high carrier 254 temperature (T_c). (41, 42) The T_c can be extracted by fitting the high energy tail in the TA 255 spectra to a Boltzmann distribution, as shown in Fig. 4I. (42) After generation from 256 photoexcitation above the bandgap, hot carriers will release their excess kinetic energy by 257 phonon emission and cooling down, leading to energy losses in the photoelectric 258 259 conversion process. (43) The hot carrier cooling process can be fit with a bi-exponential function to determine the hot carrier lifetime (Table S2). (37, 41) After the introduction of 260 MPH, the hot carrier lifetime shows a slight increase from 12.1 to 12.9 ps, showng that the 261 MPH will not induce excess energy loss in this process. The charge transport process 262 between PTAA and FAPbI3 was examined using the long-term TA spectra of the stacks of 263 these two layers (Fig. 4J and fig. S16). The evolution of photoinduced bleaching peak 264 265 intensity (at 1.58 eV) with time is shown in Fig. 4K and fit with tri-exponential function. τ_1 is characteristic of the defect-mediated recombination in the perovskite. An increase in 266 τ_1 from 315 to 1161 ps demonstrates the excellent passivation effect of MPH, in keeping 267 the TRPL and SCLC measurements. (38) τ_2 is assigned to the hole injection from the 268

perovskite into PTAA, which also increases with the introduction of MPH (from 1.4 ns to 269 270 23 ns). (44) This may be due to the type-I band offset between 3D and 2D perovskite retarding hole transport. (45) We note that the wide-bandgap 2D perovskite can also 271 increases the activation energy for thermal charge generation in the perovskite/PTAA 272 interface, effectively loweing the dark current density of the device (Fig. 4L), as shown in 273 Fig. 3A. (45, 46) The efficient passivation of defects guarantees that the carriers to go 274 through the transport process without recombination, leading to higher quantum 275 efficiency.(47) 276

For an image sensor, a curved surface is the preferred shape to match the curved focal 277 plane of the lens system. (48, 49) For example, the advanced "lobster eye" soft X-ray 278 telescope shows a focal plane with spherical shape (Fig. 5A).(50) Using traditional flat 279 image sensor in such system will introduce vignetting problems and limit the field of view. 280 (48, 49) Here the feasibility of fabricating curved imager sensors with the perovskite 281 based soft X-ray photodiode was investigated. First, a perovskite photodiode on a flexible 282 polyethylene naphthalate (PEN) substrate is shown with a stable soft X-ray response (Fig. 283 5B). Then, we fabricated 10×1 line arrays of the photodiode on the flexible substrate and 284 bent them into a curved shape (Fig. 5C). Considering the practical difficulties of array test 285 in a synchrotron radiation chamber and the performance similarity between the device 286 under visible light and soft X-ray irradiation, 520 nm light was used for convenience to 287 examine the performance of each pixel. Whether under dark or illumination conditions, 288 the curved imaging array showed excellent uniformity and a good photo-to-dark current 289 ratio. The image sensing functionality of the photodiode was verified with 10×10 imaging 290 arrays on a glass substrate (Fig. 5D). The array shows good uniformity of dark and light 291 current with no defective pixels (Fig. 5E). When a photomask with "USTC" was 292 introduced, the array produced a sharp pattern with illumination (Fig. 5F). The 293 performance of our perovskite based soft X-ray photodiode was compared to 294 representative commercial and published soft X-ray detectors (Table 1). Our perovskite 295 photodiode had an excellent comprehensive performance with low dark current, high 296 responsivity and fast response. We note that the responsivity of our device was several 297 orders of magnitude greater than that reported previousoy and comparable to commercial 298 299 Si-based devices in the soft X-ray region.

300 Discussion

In summary, a high-performance soft X-ray detectors based on low-cost solution-301 processed perovskite photodiodes are demonstrated in this work. The design of the device 302 was optimized to minimize the shadowing of "dead layers". With a multidimensional 303 perovskite heterojunction, the dark current density of the device was reduced by nearly 304 one order of magnitude and the response to soft X-rays increased by nearly one order of 305 magnitude. A high responsivity of 0.161 A/W (@500 eV), an excellent quantum efficiency 306 of 8×10^3 %, a low dark current density of 1.18×10^{-9} A/cm², and short response/decay time 307 of 81/28 µs were achieved. The responsivity and quantum efficiency of our device are 308 several orders of magnitude greater than previously reported and comparable to 309 commercial Si-based devices. Based on this high-performance device structure, flexible 310 and curved soft X-ray imaging arrays were demonstrated with stable soft X-ray response 311 and excellent uniformity. In addition, a 10×10 imaging array on a glass substrate showed 312 good image sensing functionality. This work paves the way for perovskite photodiodes to 313 serve as practical, highly cost-effective imaging sensors for soft X-ray system. 314

- 315
- 316

317 Materials and Methods318

319 Materials

Lead iodide (PbI₂, 99.999%), formamidinium iodide (FAI, 98%), bis(trifluoromethane) 320 sulfonimide lithium salt (Li-TFSI, 99.95%), n-Octylammonium iodide (OAI), anhydrous 321 dimethylformamide (DMF, 99.8%), anhydrous dimethyl sulfoxide (DMSO, 99.9%), 322 anhydrous isopropanol (IPA, 99.5%), anhydrous chlorobenzene (CB, 99.8%), 4-tert-butyl 323 pyridine (TBP, 98%), anhydrous acetonitrile (ACN, 99.8%) were purchased from Sigma-324 Aldrich. Poly[bis(4-phenyl) (2,4,6-trimethylphenyl)amine] (PTAA, $M_n = 6000-15000$) was 325 purchased from Xi'an Polymer Light Technology Corp (China). Tin (iv) oxide (SnO₂) 326 colloid dispersion (in H₂O) and methylammonium chloride (MACl, 99.9%) were 327 purchased from Advanced Election Technology Co., Ltd. All the chemicals are used as 328 received without further purification. Indium Tin Oxide (ITO) glass (15 Ω /sq) and ITO on 329 polyethylene naphthalate (PEN) substrate were purchased from Advanced Election 330 Technology Co., Ltd. 331

332 **Device Fabrication**

Patterned ITO glass was cleaned in an ultrasonic bath with deionized water, detergent, 333 deionized water, acetone, ethanol, and isopropanol for 15 min, respectively, followed by a 334 UV-ozone treatment for 20 min. SnO₂ colloid precursor was diluted by deionized water 335 $(SnO_2 : H_2O = 1:4)$ and put in ultrasonic ice water bath for 25 min before use. Then the 336 SnO_2 dispersion was spin coated onto the substrate at 3500 rpm for 25s and annealed in 337 ambient air at 180 °C for 30 min. A UV-ozone treatment for 10 min was conducted before 338 transferring the ITO/SnO₂ substrate to N₂-filled glove box. 1.8 M of PbI₂ and FAI in 339 DMF:DMSO (6: 1) solvent with 35 mol% MACl was filtered and then deposited by spin 340 coating at 1000 and 5000 rpm for 10 and 20 s, respectively. During the 5000-rpm spin 341 coating program, 100 µL of CB was poured on the spinning substrate at the 15th second. 342 Then the ITO/SnO₂/perovskite substrate was annealed in ambient air (35% humidity) at 343 150 °C for 10 min, followed by annealing in glove box at 100 °C for 10 min. For device 344 with MPH, OAI solution (3.86 mg/mL, in IPA) was spin coated onto the perovskite 345 346 surface at 3000 rpm for 30 s and annealed at 100 °C for 10 min. The hole transport material solution is consisted of 20 mg PTAA, 8 µL TBP, 15 µL Li-TFSI solution (170 347 mg/mL, in ACN), and 1 mL toluene. To get a PTAA layer with different thickness, the 348 solution was diluted to various concentration before being deposited on the perovskite 349 layer at 3000 rpm for 30 s. Finally, Au film with different thickness was thermally 350 evaporated as top electrode. Typically, the active area of the individual device is 0.1071 351 cm^2 . 352

For flexible device, PEN substrate with patterned ITO was cleaned in ultrasonic bath with 353 ethanol for 5 min, followed by a UV-ozone treatment for 10 min. SnO₂ colloid precursor 354 was diluted by deionized water (SnO₂ : $H_2O = 1:1$) and put in ultrasonic ice water bath for 355 25 min before use. Then the SnO₂ dispersion was spin coated onto the substrate at 5000 356 rpm for 60s and annealed in ambient air at 130 °C for 20 min. Notably, the SnO₂ layer was 357 spin-coated twice. The fabrication of other layers of the flexible photodiode was the same 358 as the rigid one. As for the fabrication of imaging array, ITO glass was patterned through 359 lithography and inductively coupled plasma etching to form bottom electrode line (ITO, 360 200 µm wide) before experiment. Special shadow mask was used to define top electrode 361

line (Au, 250 µm wide) vertical with the ITO line during the thermal evaporation. The
 pixel size is determined by the overlap of the ITO and the Au electrode. The other step of
 the fabrication was the same as the process to fabricate rigid individual device.

365 Film characterization:

Grazing-incidence wide-angle X-ray scattering (GIWAXS) was measured at beamline 366 7.3.3 at Advanced Light Source (ALS) at Lawrence Berkeley National Laboratory 367 (LBNL, USA). All samples for GIWAXS were radiated at 10 keV X-ray with various 368 incidence angle. The surface morphology and cross-sectional image of the perovskite was 369 investigated by scanning electron microscope (SEM, Hitachi SU8220). The absorption 370 spectrum of perovskite was estimated by UV-vis-NIF spectrometer (Shimadze 3700 371 DUV). The steady-state and time-resolved photoluminescence (PL and TRPL) was 372 measured using a Horiba Fluorolog-3 and DeltaFlex system, respectively. A PHI 5000 373 VersaProbe III system with a monochromatic Al Ka X-ray source was used to perform X-374 ray photoelectron spectroscopy (XPS) test. The thickness of the PTAA layer was 375 376 estimated by a profiler (Dektak XT). The transient absorption measurements are 377 conducted with fundamental laser (10 kHz) generated by Yb:KGW regenerative amplifier. Optical parametric amplifier used to produce 3.1-eV photoexcitation pulse (with an 378 intensity of 3.2 mW and a pulse duration ~250 fs). Optical bench directed both lasers, with 379 fundamental laser focused into sapphire crystal to generate white light probe. 380 Photoexcitation pulse frequency reduced to 5 kHz using chopper. Both lasers focused onto 381 sample in 1-mm cuvette, probe signal detected by CCD. 382

383 Device performance characterization

The device performance under soft X-ray was tested at beamline BL07W of national 384 synchrotron radiation laboratory (NSRL, China). A standard AXUV-100G photodiode 385 was used to calibrate the photon flux before test. During the test, the electrical properties 386 of the device were examined by a Keithley 4200 Parameter Analyzer. To record the device 387 performance under 520 nm light (for both individual device and imaging array), a mLaser 388 laser source, a Keithley 6482 Picoammeter, and a probe station in a N₂-filled glovebox 389 390 were adopted. For imaging array, the current was recorded pixel by pixel, so as the light illumination. The quantum efficiency of the device across the visible light region was 391 measured on a xenon lamp-based system (Newport TLS260-300X, USA). The transient 392 photocurrent (TPC) under 520 nm light was measured using a waveform generator (Rigol 393 DG822), a pre-amplifier (Stanford Research Systems SR570), and a digital oscilloscope 394 (PicoScope 4262). 395

396 Soft X-ray intensity distribution simulation

The distribution of the Soft X-ray intensity throughout the Si, FAPbI₃, and photodiode was calculated following the Beer-Lambert Law, which can be expressed as:

$$I = I_0 \exp\left(\frac{-t}{t_0(E)}\right)$$

400 Where *I* is the soft X-ray intensity through material of thickness *t*, I_0 is the incident 401 intensity and the $t_0(E)$ stand for the attenuation length of soft X-ray in this material, which 402 was taken from the CXRO database.

403 Space-charge-limited current measurements

404 The SCLC measurements were performed on electron-only device with structure of 405 ITO/SnO₂/perovskite (with or without MPH)/ C_{60} /BCP/Ag. The defect density is calculated 406 as:

$$407 n_t = \frac{2\varepsilon\varepsilon_0 V_{TFL}}{e\,L^2}$$

408 Where ε is the relative permittivity of FAPbI₃ perovskite (taken as 46.9 here), ε_0 is the 409 vacuum permittivity, *L* is the thickness of the FAPbI₃ film (750 nm), *e* is the elementary 410 charge, and V_{TFL} is the trap-filled limit voltage.

411 Fitting models for the decay process

412 The TRPL, hot carrier cooling process, and bleach peak intensity decay process is fitted 413 with biexponential or triexponential equation, which can be express as:

414
$$I = I_0 + \sum_{i=1}^n A_i \exp\left(\frac{-t}{\tau_i}\right)$$

415 Where t is the time, τ_i and A_i is the life time and amplitude of the process, respectively. For 416 biexponential equation, n=2; while for triexponential equation, n=3. The average lifetime 417 (τ_{ave}) is obtained by:

418
$$\tau_{ave} = \frac{\sum_{i=1}^{n} A_i \tau_i^2}{\sum_{i=1}^{n} A_i \tau_i}$$

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Author contributions: Q.H. conceived the idea. Q.H., X.Z and X.L. directed and 552 supervised the project. Q.H. and P.T. designed all the experiments. P.T. and T. L. 553 554 fabricated and characterized the photodiodes, prepared the samples for characterizations. Y.Y and Y.C. supported the device fabrication. Y.G., S.Y. helped to characterize the soft 555 X-ray response. Z. L. conduct the TAS experiments. X.W. and Z.F. conducted the 556 GIWAX measurements. Y.L., H.D., X.J., X. H., S. J., J.Z., F. F., S.Y., T.P.R. and S.L. 557 gave suggestions and comments. P.T. and T.L. wrote the manuscript. Q.H., X.Z., X. L. 558 and Y.L. revised the paper. All the authors discussed the results and commented on the 559 560 paper.

562 **Competing interests:** The authors declare no competing financial interests.

564 **Data and materials availability:** Supporting information was available in the online 565 version of the paper. Correspondence and requests for materials should be addressed to 566 Q.H., X.Z. and X. L..

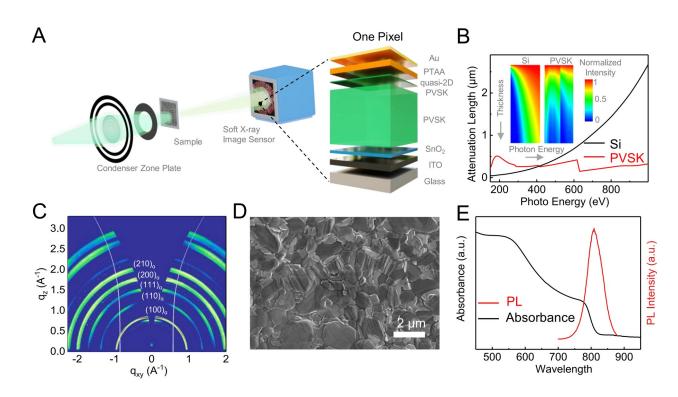


Fig. 1. Device structure and material characterization. (A) Schematic diagram of one soft X-ray microscopy system with perovskite (PVSK) photodiode array as image sensor. (B)
Comparison of attenuation length of soft X-ray in Si and FAPbI₃, while inset depicts the variation of soft X-ray intensity throughout these two materials with the same thickness (750 nm). FAPbI₃
shows more uniform attenuation length and light intensity distribution across the soft X-ray region.
(C) The 2D GIWAXS pattern of FAPbI₃ film at beam incidence angle of 0.5°. (D) Top-view SEM image of the FAPbI₃ perovskite film. (E) Absorption and PL spectra of FAPbI₃ perovskite.

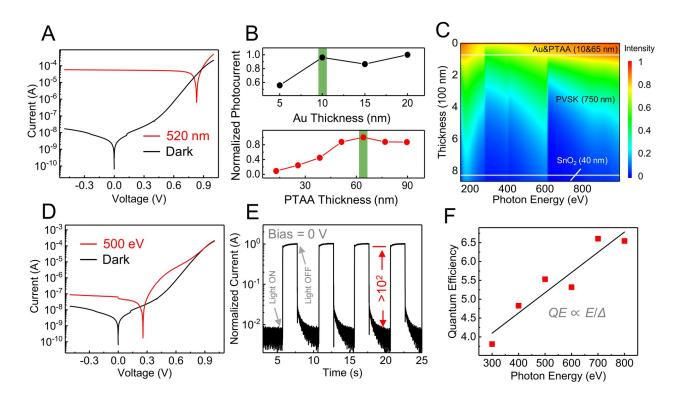


Fig. 2. Performance of the control device. (A) Photovoltaic behavior of the perovskite 581 photodiode under 520 nm light (1.3 mW/cm²). (B) Dependence of photocurrent (under 520 nm 582 583 light) of the device on the thickness of Au and PTAA layer, respectively. The optimal thickness is 10 and 68 nm for Au and PTAA, respectively. (C) Distribution of soft X-ray intensity throughout 584 the photodiode with adjusted structure. (D) I-V curve of the perovskite photodiode in the dark and 585 under 500 eV soft X-ray with photo flux of 6.92×10^{10} photons/s. (E) Light switching response of 586 the perovskite photodiode at 0 V under 500 eV soft X-ray. (F) The linear relationship between 587 device quantum efficiency (OE) and photon energy (E), which is in line with the given formula. 588

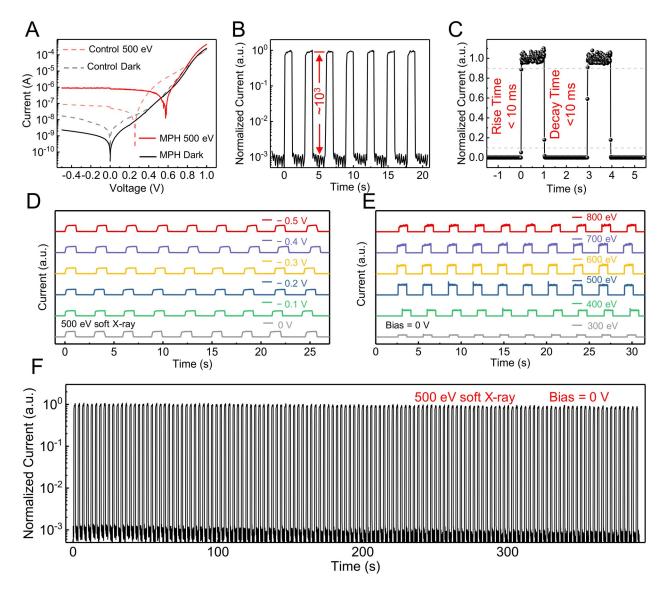


Fig. 3. Performance of the multidimensional perovskite heterojunction (MPH) device. (A) Comparison of I-V curves of the perovskite photodiode with and without MPH (in the dark and under 500 eV soft X-ray). (B) Response of the MPH device to intermittent illumination of 500 eV soft X-ray. (C) Close-up view of the typical response period of the device in linear scale, which shows rise and decay time smaller than 10 ms. (D, E) Light switching response of the photodiode with MPH at various voltages and different photon energy, respectively. (F) Multi-cycle timedependent response of the MPH device under the excitation of 500 eV soft X-ray at zero bias.

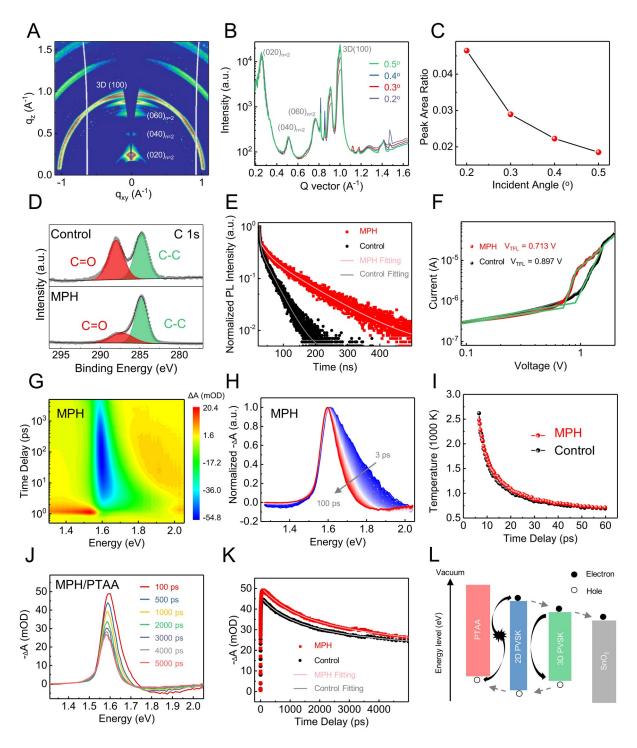
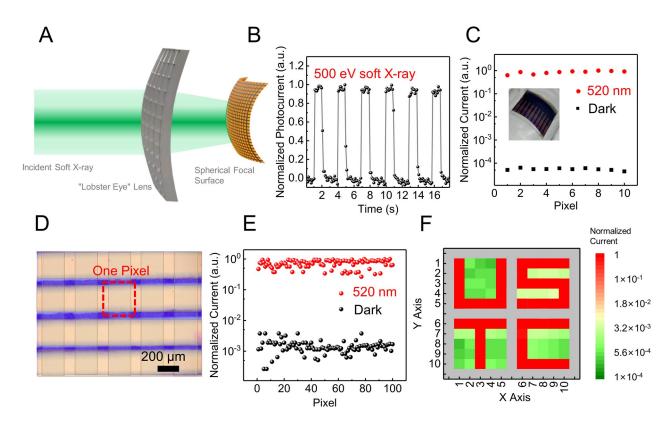


Fig. 4. Characterization of the effect of MPH on the device. (A) 2D pattern of the GIWAXS of the multidimensional heterojunction, recorded under an incidence angle of 0.5°. (B) Integrated line 601 file GIWAXS of the MPH film with various incidence angle. (C) The area ratio of $(040)_{n=2}$ peak to 602 603 3D(100) peak as a function of incidence angle. (D) XPS C 1s core level spectra of FAPbI₃ perovskite with and without MPH, respectively. (E) TRPL decays of the control and MPH film on 604 605 ITO/SnO_2 substrate. (F) The dark I-V characteristics of electron-only device with structure of ITO/ SnO₂/perovskite (with or without MPH)/C₆₀/BCP/Ag, and V_{TFL} stands for the trap-filled limit 606 voltage. (G) Color plot of the transient absorption (TA) spectra of the MPH film on glass substrate. 607 608 (H) Normalized TA spectra of the MPH sample from 3 to 100 ps. (I) The hot carrier temperature 609 as a function of delay time. (J) Evolution of the TA spectra of the MPH/PTAA film probed at

varied delays as indicated. (K) Transient band edge bleach kinetics of the perovskite/PTAA film 611 with and without MPH. (L) Schematic band diagram of the photodiode with MPH.



613 Fig. 5. Demonstration of curved image sensor. (A) Schematic diagram of the "lobster eye" soft 614 X-ray imaging system. (B) Light switching response under 500 eV soft X-ray of the flexible 615 perovskite photodiode on PEN substrate at self-powered mode. (C) The dark and light current of 616 each pixel of a flexible 10×1 line array under a bending radius of 1.4 cm (corresponding to a 617 bending angle of $\sim 60^{\circ}$). Inset shows the curved array. (D) Optical image of parts of the 10×10 crossbar array with one pixel as $200 \times 250 \ \mu\text{m}^2$. (E) Dark and light current mapping of the 618 619 photodiode array. (F) Imaging results of the imaging array under photomask. The image has been rearranged for clarification. Focusing light spot was used during the test to evade crosstalk issue. 620

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622Table 1. Comprehensive comparison of the perovskite based soft X-ray photodiode (with623MPH) with other soft X-ray detectors from market and literature. The responsivity and624quantum efficiency of our device are several orders of magnitude larger than the previous reports625and comparable to commercial Si based device.

Material	structure	Dark current density (nA/cm ²)	Sensitivity (µC/Gy/cm²)	Responsivity (A/W)	Quantum Efficiency (%)	Decay Time (µs)	Temperature (°C)	Ref
Si	PN diode	0.736 (@10 mV)		0.268 (@500 eV)	1.37×10 ⁴ (@500 eV)	10	RT	А
Si	CCD image sensor			0.235 (@500 eV)	1.2×10 ⁴ (@500 eV)		-70	В
Si	Cmos image sensor			0.155 (@500 eV)	7.9×10 ³ (@500 eV)	< 21	-20	С
SnS	MSM	~6×10 ⁴ (@1 V)	1.15×10 ⁴ (@600 eV)	~2×10 ⁻⁵ (@600 eV)	~1.2 (@600 eV)	2×10 ³	RT	(9)
CsPbBr ₃ Perovskite	MSM	~1×10 ⁴ (@0.1 V)	1450			2.7×10 ⁴	RT	(13)
CrSiTe ₃	MSM	~8×10 ⁷ (@1 V)	463 (@800 eV)			1.06×10 ⁵	RT	(14)
Cs _{0.1} FA _{0.9} PbI ₃ Perovskite	diode	~7 (@1 mV)	5×10 ³ (@700 eV)	~5×10 ⁻³ (@700 eV)	~3.5×10 ² (@700 eV)	3×10 ³	RT	(15)
FAPbI ₃ Perovskite	diode	1.18 (@2.5 mV)		0.161 (@500 eV)	8×10 ³ (@500 eV)	28	RT	This Work

 --: not mentioned or ambiguous in corresponding reference. RT: room temperature

A: AXUV100G from Opto Diode Corp.; B: PIXIS-XO: 1024B from Princeton Instruments Inc.; C: GSENSE400BSI from Gpixel

635 Supplementary Materials

636 Supporting information for this article is available online.